

Nelson Felix

List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/10854667/publications.pdf>

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7
papers

318
citations

1684188

5
h-index

1872680

6
g-index

7
all docs

7
docs citations

7
times ranked

436
citing authors

#	ARTICLE	IF	CITATIONS
1	Directed self-assembly of block copolymers for 7 nanometre FinFET technology and beyond. Nature Electronics, 2018, 1, 562-569.	26.0	87
2	DSA patterning options for FinFET formation at 7nm node. Proceedings of SPIE, 2016, , .	0.8	6
3	Molecular glass resists for next generation lithography. Proceedings of SPIE, 2008, , .	0.8	6
4	Phenolic molecular glasses as resists for next-generation lithography. , 2007, 6519, 1291.		24
5	Sub-50 nm feature sizes using positive tone molecular glass resists for EUV lithography. Journal of Materials Chemistry, 2006, 16, 1470.	6.7	83
6	Molecular Glass Resists for High-Resolution Patterning. Chemistry of Materials, 2006, 18, 3404-3411.	6.7	104
7	New PFOS Free Photoresist Systems for EUV Lithography. Journal of Photopolymer Science and Technology = [Fotoporima Konwakai Shi], 2006, 19, 515-520.	0.3	8